



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of

Hirofumi HARADA :

Serial No. 10/812,443 : Group Art Unit: 2823

Filed: March 30, 2004 : Examiner- Fernando L. Toledo

For: METHOD OF MANUFACTURING A :

VERTICAL MOS TRANSISTOR

(As Amended) : Docket No. S004-5253

Mail Stop AMENDMENT COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE

S I R:

In response to the Office Action dated October 31, 2005, applicant preliminarily amends his application as follows:

ADDITIONAL FEES:

No additional fees are believed required in connection with this response; however, should it be determined that a fee is due, authorization is hereby given to charge any such fee to our Deposit Account No. 01-0268.

MAILING CERTIFICATE ON PAGE 26

IN THE TITLE:

The Title of the Invention has been amended as follows:

METHOD OF MANUFACTURING A VERTICAL MOS TRANSISTOR